

Freeform Search

Database:

- US Pre-Grant Publication Full-Text Database
- US Patents Full-Text Database
- US OCR Full-Text Database
- EPO Abstracts Database
- JPO Abstracts Database
- Derwent World Patents Index
- IBM Technical Disclosure Bulletins

Term:

PECVD and (argon or krypton or helieum) and ((metal adj film) or titanium) and ((inert or noble) with (enhanc\$4 or improv\$4 or increas\$4 or

Display: 10 Documents in Display Format: - Starting with Number 1

Generate: ☐ Hit List ☒ Hit Count ☐ Side by Side ☐ Image

Search Clear Interrupt

Search History

DATE: Thursday, December 23, 2004 [Printable Copy](#) [Create Case](#)

<u>Set</u> <u>Name</u>	<u>Query</u>	<u>Hit</u> <u>Count</u>	<u>Se</u> <u>Nam</u> resu set
side by side			
	DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=OR		
L7	PECVD and (argon or krypton or helieum) and ((metal adj film) or titanium) and ((inert or noble) with (enhanc\$4 or improv\$4 or increas\$4 or accelerat\$4))	137	L7
	DB=USPT; PLUR=YES; OP=OR		
L6	L5	5799	L6
L5	"noble gas"	5799	L5
L4	L3 and noble	4	L4
L3	L2 and tetrachloride	78	L3
L2	L1 and PECVD	660	L2
L1	titanium and argon and hydrogen	18188	L1

END OF SEARCH HISTORY